

Docket No.: 245166US6CIP/jkl

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Tsutomu OKABE, et al.

SERIAL NUMBER: 10/706,977

GROUP: 1792

FILED: November 14, 2003

EXAMINER: MOORE, KARLA A.

FOR: WAFER PROCESSING APPARATUS HAVING DUST PROOF FUNCTION

**AMENDMENT AFTER ALLOWANCE UNDER 37 C.F.R. § 1.312**

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SIR:

In response to the Notice of Allowance dated June 24, 2009, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.